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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10042666	FILING DATE 01/08/2002	CLASS 427 418	SUBCLASS 523	GAU 1111 1734	EXAMINER Rodgeff Lavilla
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**APPLICANTS: Han Nianci; Xu Li; Shih Hong;

**CONTINUING DATA VERIFIED:

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 003330 USA/ETCH/METAL/JB
TITLE : Process chamber having component with yttrium-aluminum coating U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	
ISSUE FEE		Total Claims	Print Claim for O.G.
Amount Due	Date Paid		
TERMINAL		DRAWING	
DISCLAIMER		Sheets Drwg.	Figs.Drwg.
		Print Fig.	
		Primary Examiner	
		Application Examiner	
PREPARED FOR ISSUE			
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